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Date:	February 7, 2003
To:	U.S. Patent and Trademark Office Fax: 703-872-9318 Tel: 703-872-9317
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No. of pages	2 (excluding this cover sheet)

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TECHNOLOGY CENTER 2800

Applicant(s):	Pablo I. Rovira; ;		
Assignee:	Nanometrics Incorporated		
Title:	Optical Metrology System with Combined Interferometer and Ellipsometer		
Serial No.:	10/016,943	Filing Date:	December 13, 2001
Examiner:	Unknown	Group Art Unit:	Unknown

Enclosed for filing in the U.S. Patent and Trademark Office for the above-identified application are the following:

1. Power of Attorney; Revocation of Previous Powers; and Statement under 37 CFR 3.73(b) (1 page); and
2. Status Inquiry (1 page)

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**POWER OF ATTORNEY;  
REVOCATION OF PREVIOUS  
POWERS; AND  
STATEMENT UNDER 37 CFR 3.73(b)  
Application**

Application Number	10/016,943
Title	Optical Metrology System with Combined Interferometer and Ellipsometer
Filing Date	December 13, 2001
First Named Inventor	Pablo I. Rovira
Group Art Unit	Unknown
Examiner Name	Unknown
Attorney Docket No.	NAN051 US

Nanometrics Incorporated having a place of business at 1550 Buckeye Drive, Milpitas, CA 95035-7418 states that to the best of its knowledge and belief it is the assignee or is entitled to ownership of the entire right, title, and interest in and to the above-referenced patent application by virtue of an Assignment recorded with the U.S. Patent and Trademark Office as per Reel/Frame 012387/0691 and represents that the undersigned is a representative authorized and empowered to sign on behalf of Nanometrics Incorporated. See 37 C.F.R. 3.73(b).

Nanometrics Incorporated hereby revokes all powers of attorney previously given and appoints the attorneys identified by the following Customer Number with full power of substitution and revocation, to prosecute this application, and to transact all business in the U.S. Patent and Trademark Office in connection therewith. Please send all future correspondence to the attention of Michael J. Halbert (40,633) care of the address associated with the following customer number and please direct all telephone calls to the same.

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Please also update the Attorney Docket Number to NAN051 US

SIGNATURE of Applicant or Assignee of Record

Date:

2-4-03

Signature:

Name:

John D. Heaton

Title:

President and CEO